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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR: C. P. Ausschnitt)
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FOR: METHOD OF PATTERNING PROCESS METROLOGY BASED ON
 THE INTRINSIC FOCUS OFFSET

CHANGE OF CORRESPONDENCE ADDRESS FOR ALL PURPOSES

**Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
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Dear Sir:

Pursuant to 37 CFR §1.33, please change the correspondence address, (Customer No. 32074), for all purposes for the above identified patent application and resulting patent to:

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Respectfully submitted,

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